

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Arthur Sherman
App. No	:	10/683,727
Filed	:	October 10, 2003
For	:	SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	:	Kelly M Stouffer
Art Unit	:	1792
Conf No.	:	1627

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action electronically transmitted on November 26, 2008, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.